

OCT 11 2005

EXPRESS MAIL NO. EV 678997660 US

IDS Form PTO/SB/08: Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete if Known	
Sheet	1	of	1	Application Number	09/903,081
				Filing Date	July 10, 2001
				First Named Inventor	DEMARAY, Richard E.
				Art Unit	1731
				Examiner Name	HOFFMAN, John M.
				Attorney Docket Number	9140.0014-00

U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS					
Examiner Initials	Cite No. ¹	Document Number	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
		5,478,456	12-26-1995	Humpal et al.	
		6,846,765 B2	01-25-2005	Imamura et al.	

Note: Submission of copies of U.S. Patents and published U.S. Patent Applications is not required.

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		Country Code ³ Number ⁴ Kind Code ⁵ (if known)			

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation ⁶		
		DOREY, R.A., "Low temperature micromoulding of functional ceramic devices," Grant summary for GB/S84156/01 for the UK Engineering and Physical Sciences Research Council, 2 pages (2004).			
		HOWSON, R.P., "The reactive sputtering of oxides and nitrides," <i>Pure & Appl. Chem.</i> 66(6):1311-1318 (1994).			
		Office Action issued on August 4, 2005, in U.S. Serial No. 10/101,863 (Attorney Docket No. 09140-0016-00).			
		Office Action issued on August 8, 2005 in U.S. Serial No. 10/101,341 (Attorney Docket No. 09140-0017-00).			

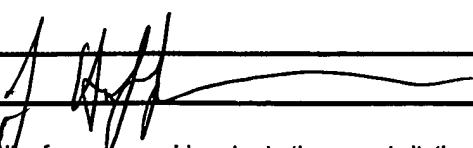
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<p style="text-align: center;">AUG 10 2005 USPTO/PTO/SB/08: Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)</p>				Complete if Known	
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		US 2005/0006768 A1	01-13-2005	Narasimhan et al.	
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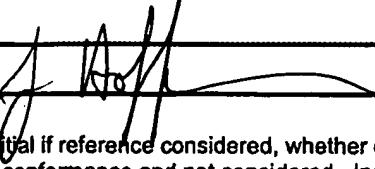
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Sheet	3	of	7	Attorney Docket Number	9140.0014-00000

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		JP 7-233469	09-05-1995	Asahi Glass Co, Ltd.	No Copy

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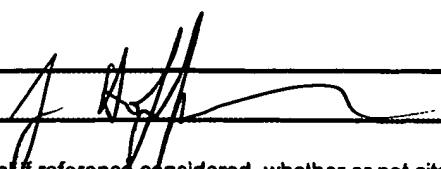
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